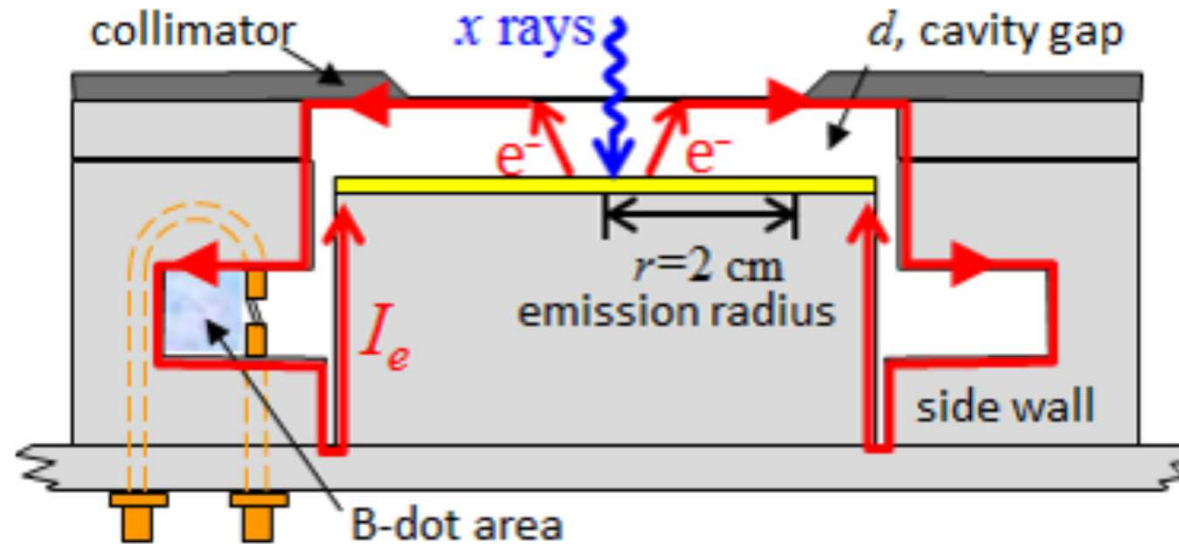


# Modeling e-Beam Interaction with Argon in 1D

Matthew Hopkins, CEA visit, 2017-12-07

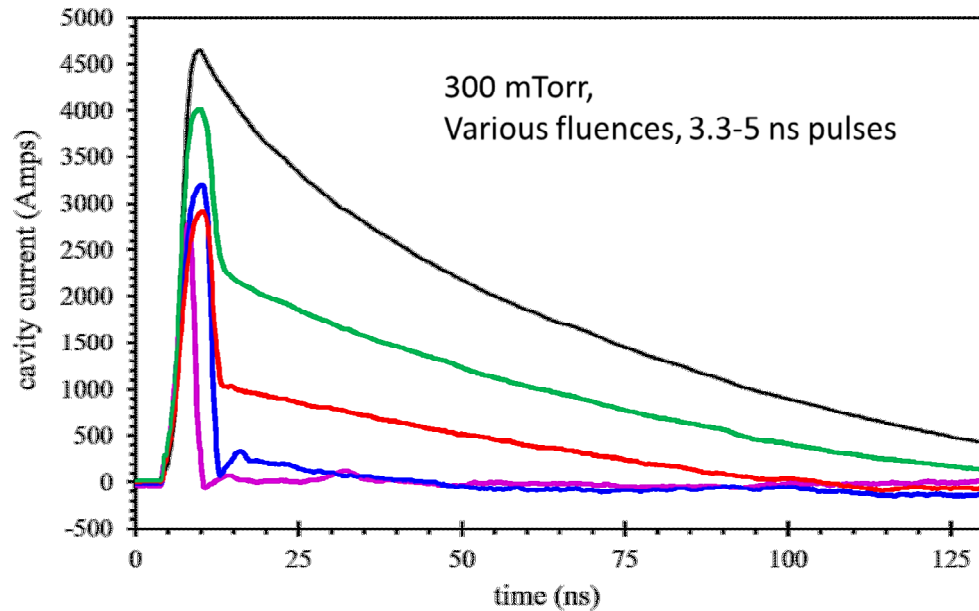
Extra thanks to: Ben Yee, Andy Fierro, Chris Moore, Ed Barnat

# Goals



- Develop high fidelity model for comparison to benchtop experiments.
- Understand the importance of more vs. less detailed plasma chemistry models.
- Stepping stone to full 3D EM-PIC-DSMC simulations.
- There has been prior work on less resolved 2D and 3D EM-PIC-MCC simulations, not presented here.

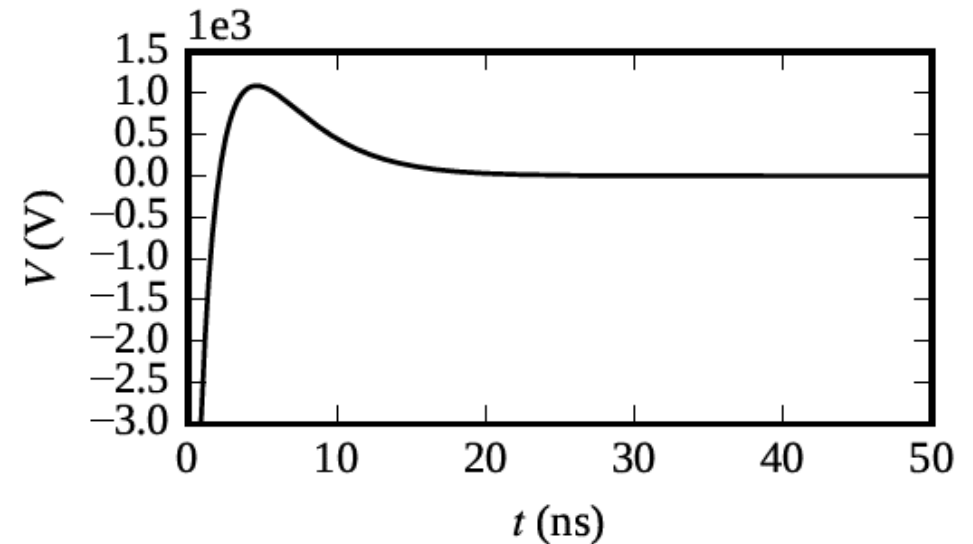
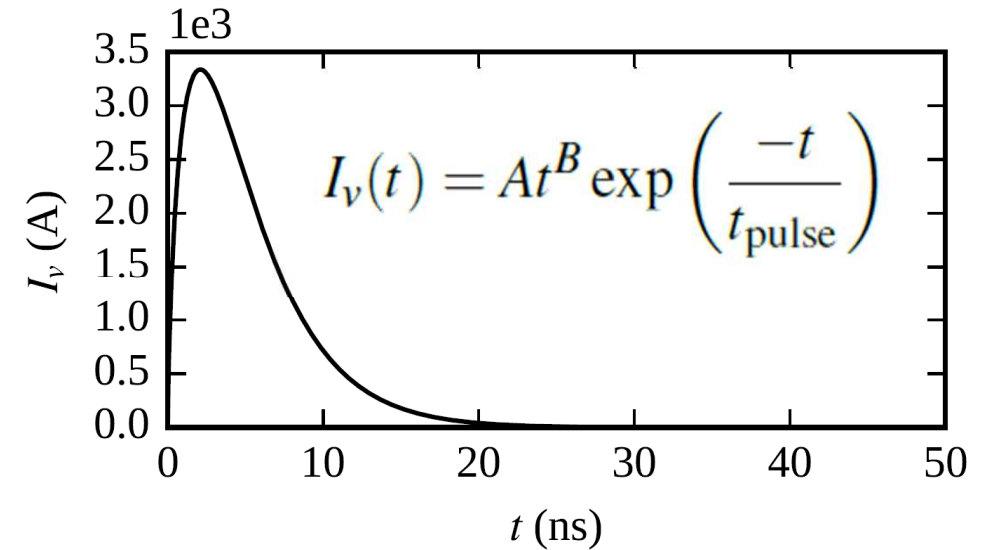
# 1D Model Setup



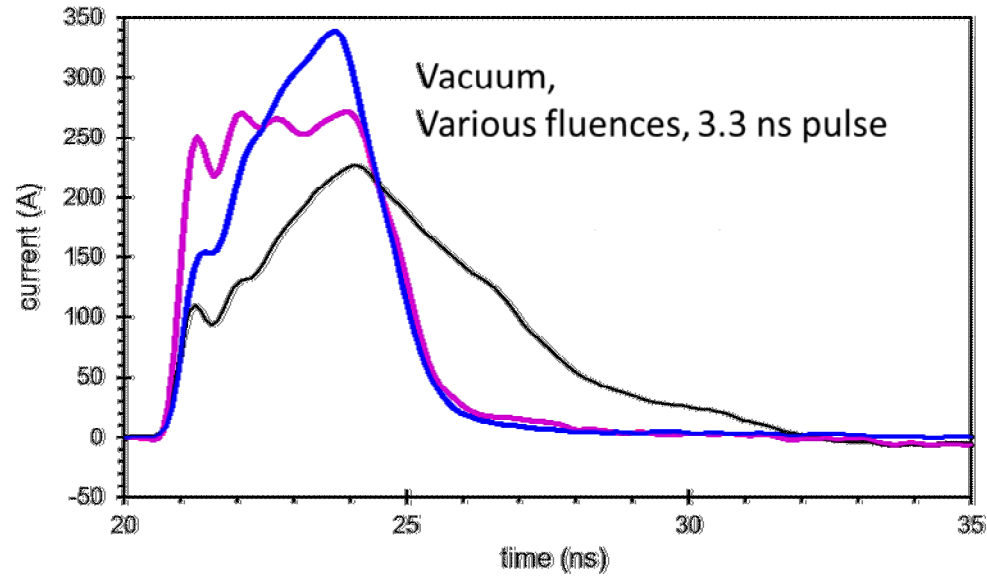
- Based on current measurements for pressurized system, set up an applied voltage waveform,

$$V(t) = L * dI_v(t)/dt$$

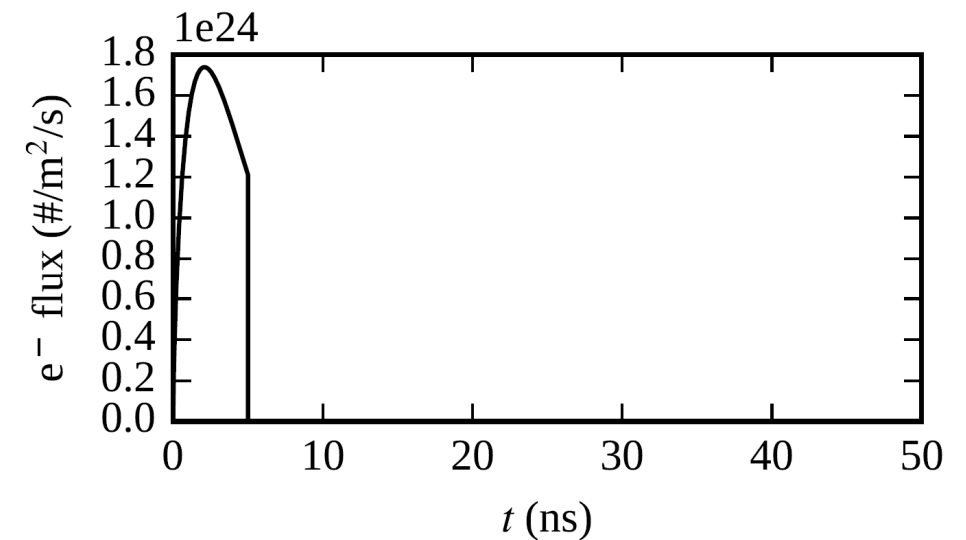
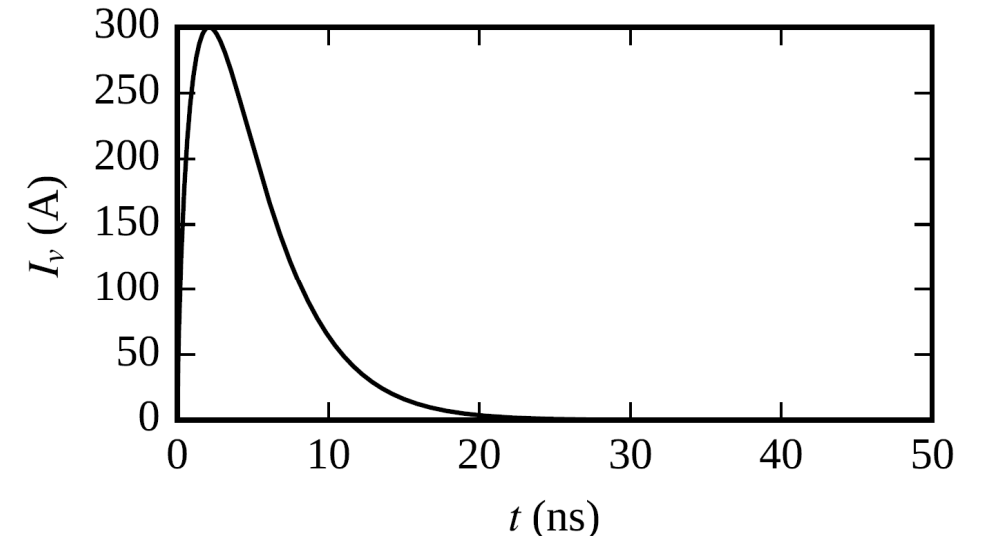
We are electrostatic!



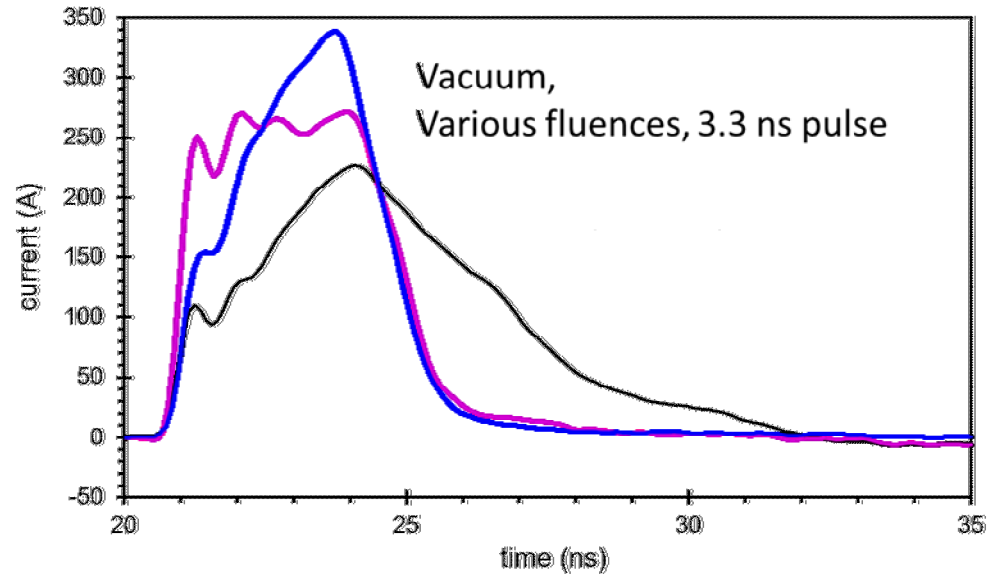
# 1D Model Setup



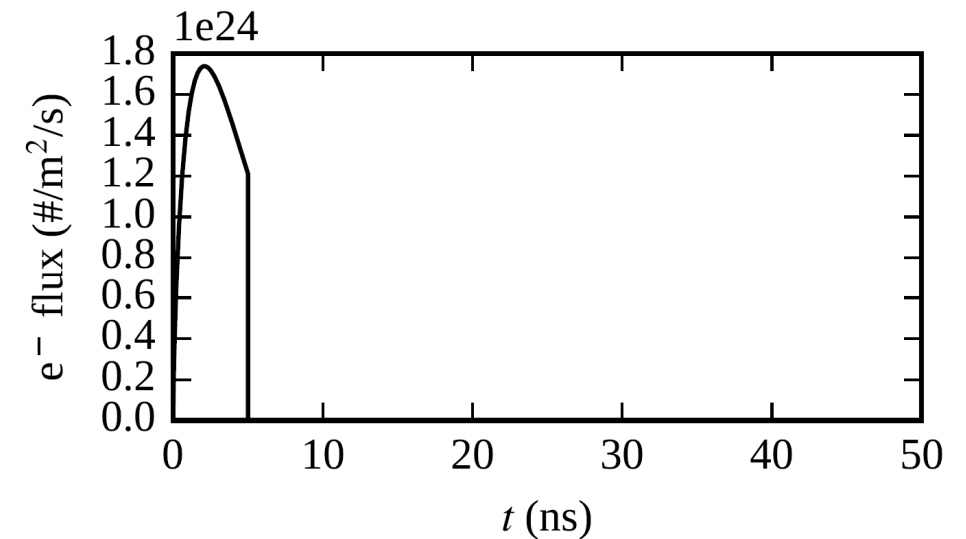
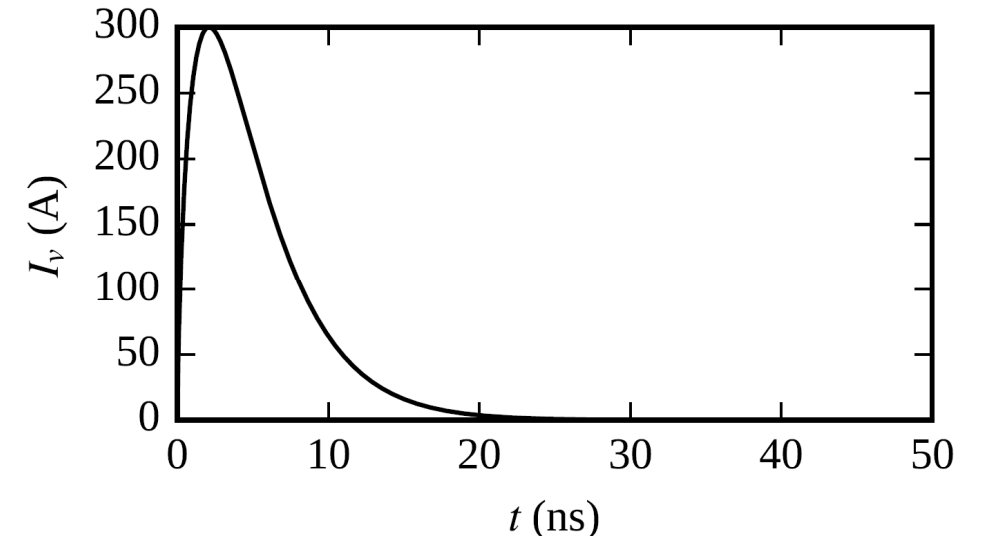
- Based on current measurements for vacuum system, set up an e<sup>-</sup> injection flux



# 1D Model Setup

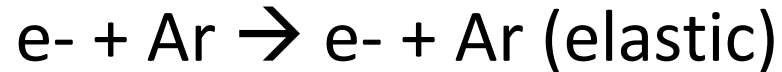


- Based on current measurements for vacuum system, set up an e<sup>-</sup> injection flux



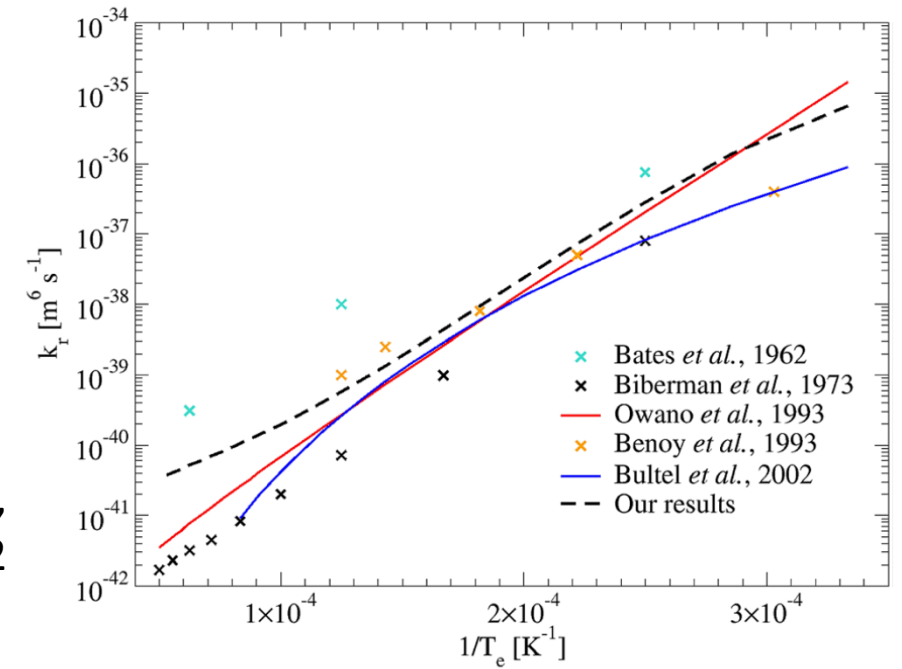
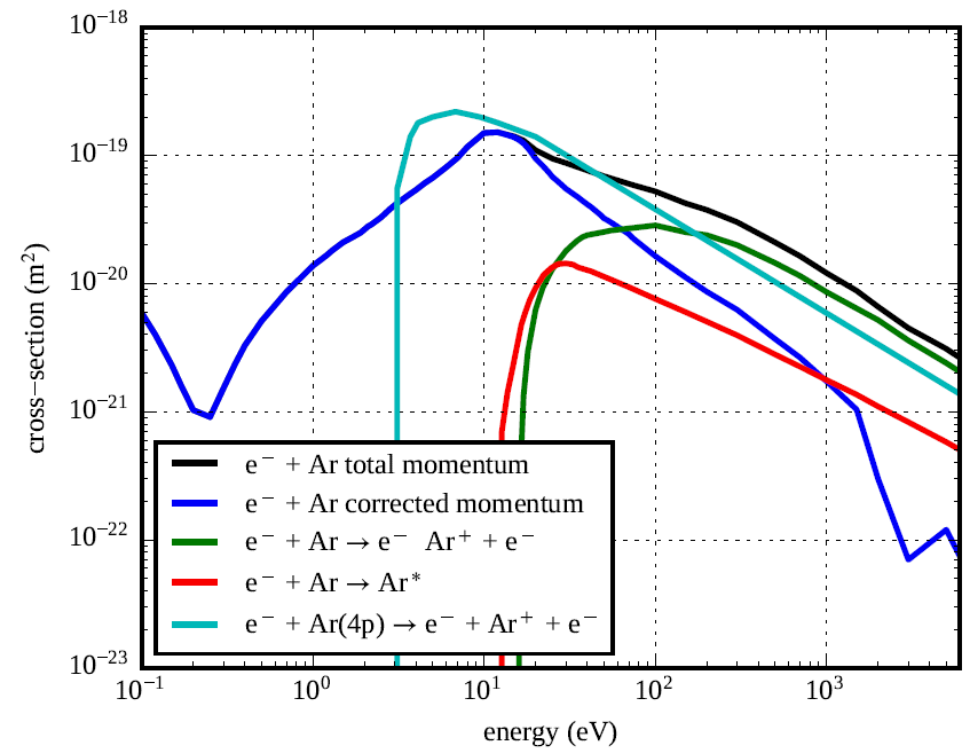
# 1D Model Setup

Chemistry to start with:

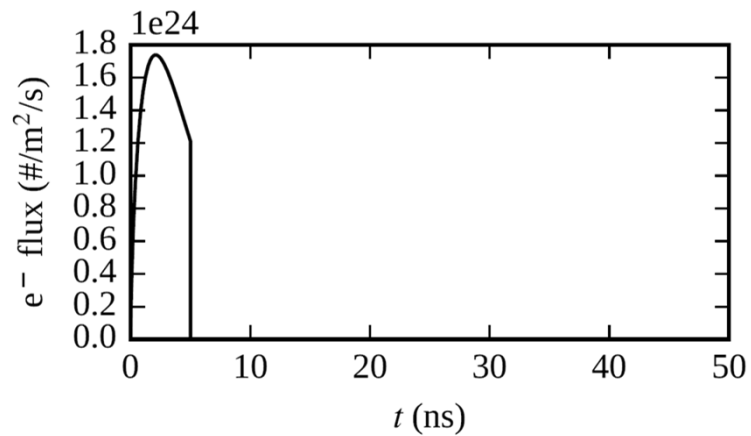


Recombination rates are complicated...

From Annaloro,  
Phys. Plasmas, 2012



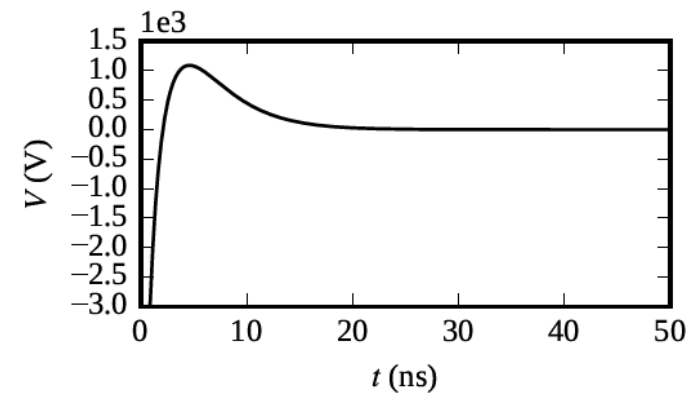
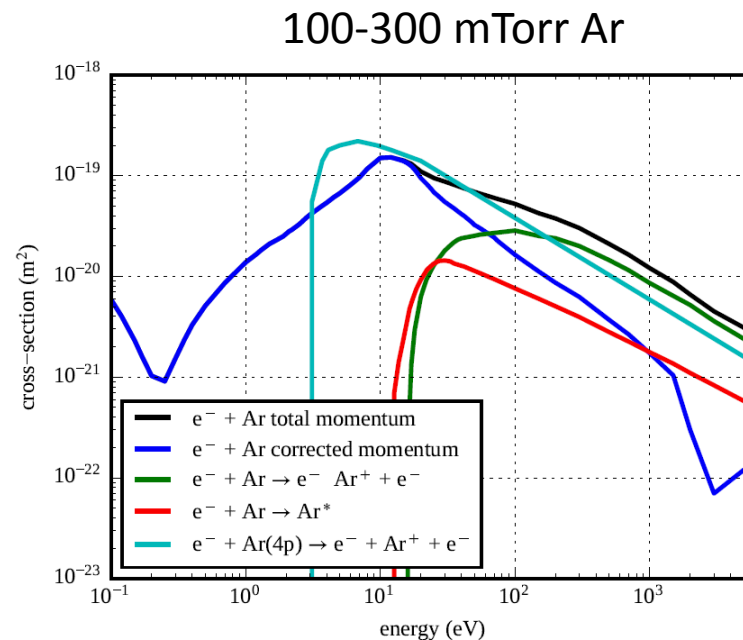
# 1D Model Setup



$e^-$  flux at  $v_x = 5$  kV

$x = 0$

$V = 0$



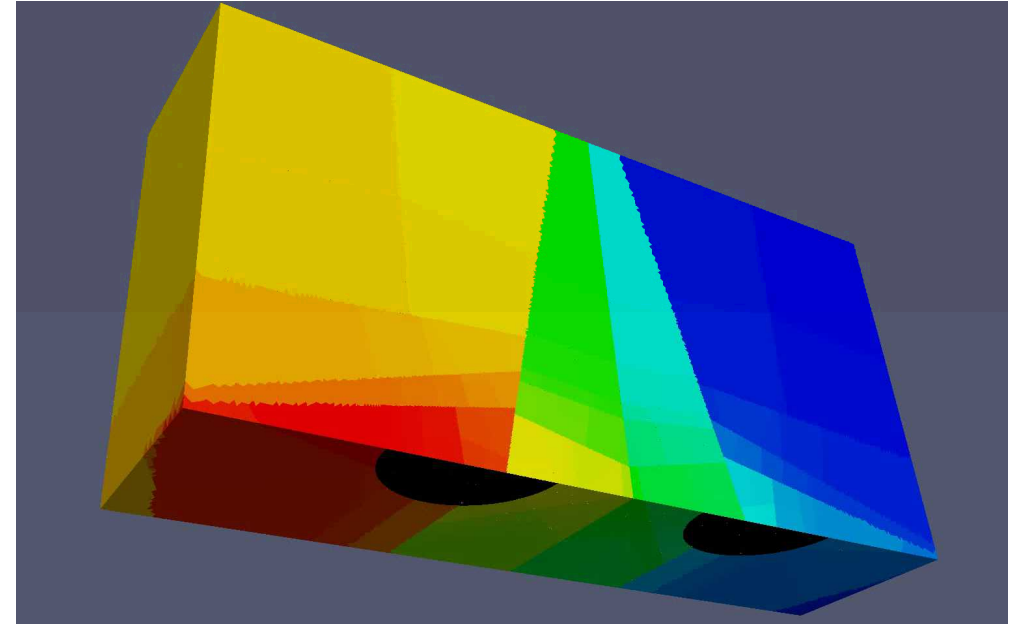
$V(t)$

$x = 1$  cm

$V(t) = L \, dl(t)/dt$

# Description of Aleph

- 1, 2, or 3D Cartesian
- Unstructured FEM (compatible with CAD)
- Massively parallel
- Hybrid PIC + DSMC (PIC-MCC)
- Electrostatics
- Fixed B field
- Solid conduction
- Advanced surface (electrode) models
- e- approximations (quasi-neutral ambipolar, Boltzmann)
- Collisions, charge exchange, chemistry, excited states, ionization
- Photon transport, photoemission, photoionization
- Advanced particle weighting methods
- Dual mesh (Particle and Electrostatics/Output)
- Dynamic load balancing (tricky)
- Restart (with all particles)
- Agile software infrastructure for extending BCs, post-processed quantities, etc.
- Currently utilizing up to 64K processors (>1B elements, >1B particles)





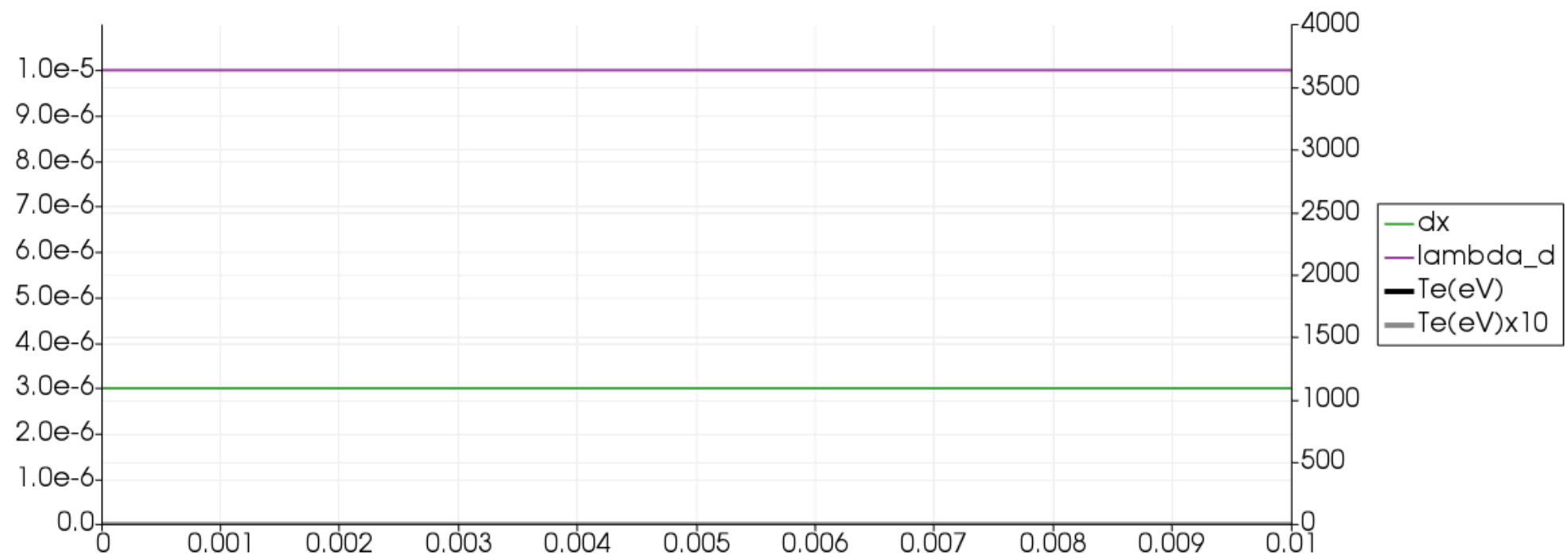
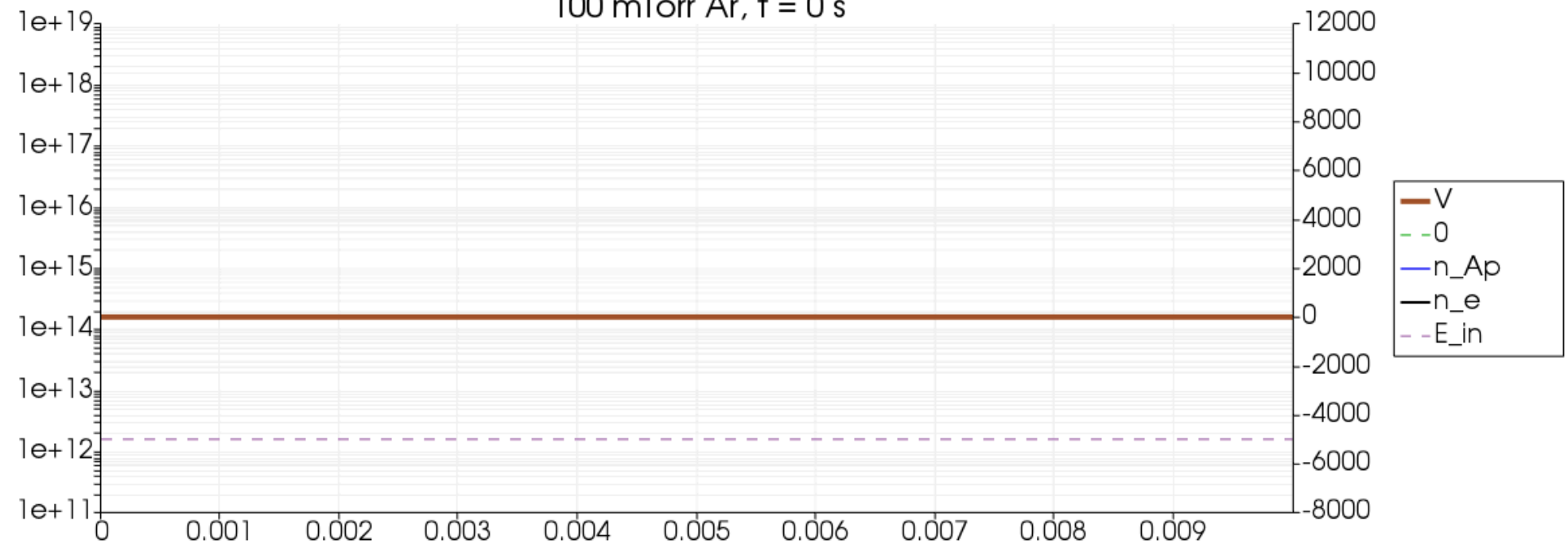
# Simulation Parameters

Constraint	Requirement
Debye length	$\Delta x < \lambda_D = \sqrt{\frac{k_B T_e \epsilon_0}{n_e q_e^2}}$
Collision mfp	$\Delta x < \lambda_c = \frac{1}{n_{bg} \sigma_{max}}$
Particle CFL	$\Delta t < \frac{v_{max}}{\Delta x}$
Plasma frequency	$\Delta t < 2/\omega_p = 2\sqrt{\frac{\epsilon_0 m_e}{n_e q_e^2}}$
Collision frequency	$\Delta t < 1/\omega_c = \frac{1}{n_{bg} \sigma_{max} v_{max}}$

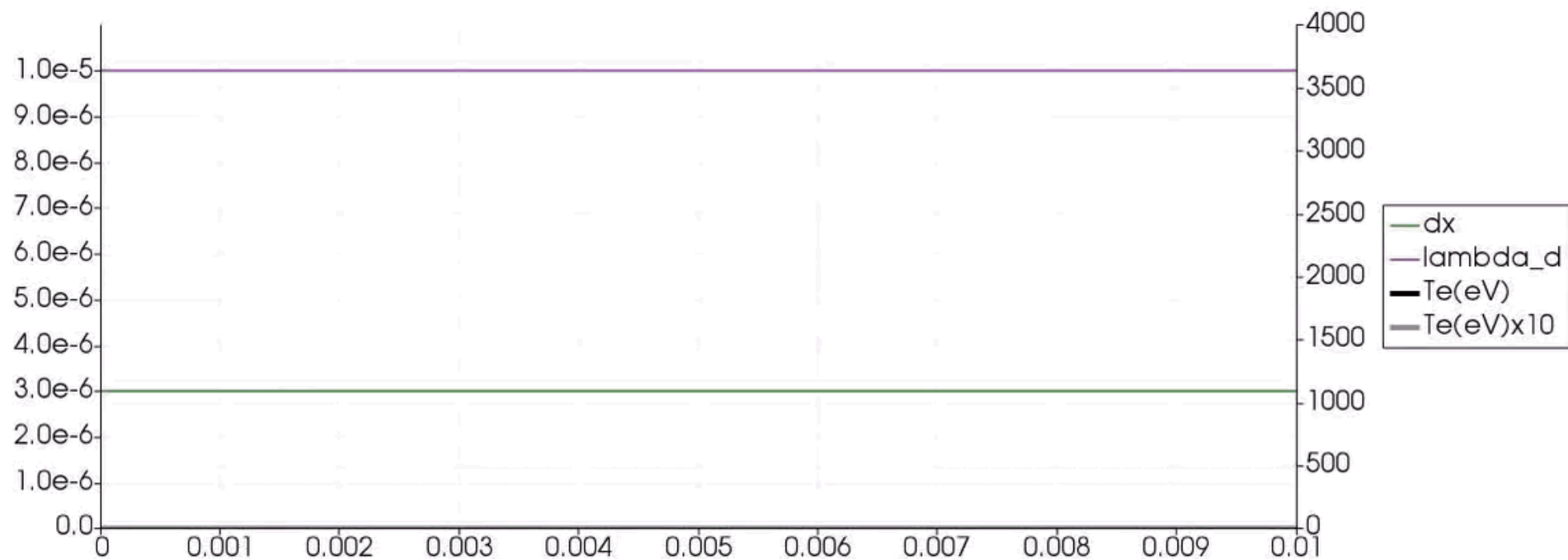
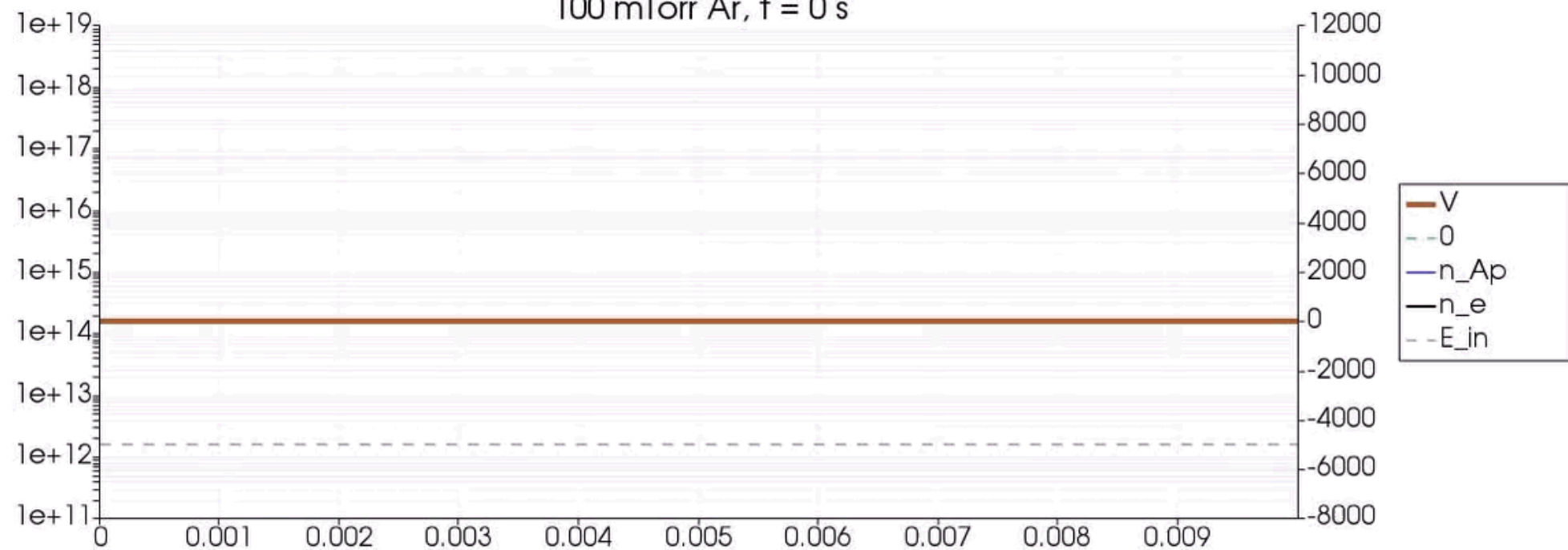
At  $T_e = 2$  eV,  $n_e = 10^{-19} \text{ m}^{-3}$ ,  $\sigma_{max} = 2 \times 10^{-19} \text{ m}^2$ , and  $n_{bg} = 9.7 \times 10^{21} \text{ m}^{-3}$ ,  
 $v_{max} = 4.2 \times 10^7 \text{ m/s}$ ,

$\lambda_D = 3.2 \text{ } \mu\text{m}$ ,  $\lambda_c = 500 \text{ } \mu\text{m} \rightarrow \Delta x = 3 \text{ } \mu\text{m}$

$v_{max}/\Delta x = 40 \text{ fs}$ ,  $2/\omega_p = 11 \text{ ps}$ ,  $1/\omega_c = 12 \text{ ps} \rightarrow \Delta t = 80 \text{ fs}$

100 mTorr Ar,  $t = 0$  s

100 mTorr Ar,  $t = 0$  s



# More Results

